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## Freeform Optics for Optical Payloads with Reduced Size and Weight Phase II– Aug 27 2018 Paul Harmon, ProgrNASA 18 C0152 am Manager and PI

#### Contract: 80NSSC18C0152

Performance Period: 30 May 2018 through 29 May 2020

#### **Contracting Officer:**

NASA Shared Services Center (NSSC) SBIR/STTR Contracting Officer; <u>NSSC-ContactCenter@nasa.gov</u> Phone: 1-877-677-2123

#### **Technical Manager:**

Joseph M. Howard, Ph.D. Joseph.M.Howard@nasa.gov Optics Branch, Code 551 NASA Goddard Space Flight Center Bldg 5, Room C330 8800 Greenbelt Road Greenbelt, MD 20771 Contract No 80NSSC18C0152 Voxtel, Inc, 15985 NW Schendel Ave, Suite 200, Beaverton, OR 97006-6703, Expiration of SBIR Data Rights May 29, 2023. The Government's rights to use, modify, reproduce, release, perform, display, or disclose technical data or computer software marked with this legend are restricted during the period shown as provided in paragraph (b)(4) of the Rights in Noncommercial Technical Data and Computer Software Small Business Innovation Research (SBIR) Program clause contained in the above identified contract. No restrictions apply after the expiration date shown above. Any reproduction of technical data, computer software, or portions thereof marked with this legend must also reproduce the markings.



#### **ΥΟΧΤΕΙΝΑΝΟ**

### **Unmet Need: Correct Aberrations in Cubesat Optics**



Typical two mirror optical path for small satellites; space is limited eff

A rotationally symmetric mirror (left) based optical path is not as space efficient as one based on a non-rotationally symmetric freeform mirror (right)

- Compact high-quality optics in a cubesat volume requires freeform mirrors in order to realize necessary design degrees of freedom (DOF)
- Mfg and assy of freeform reflectors expensive and time consuming for each unit
- Process: measure assy aberrations, then correct with VIRGO freeform GRIN phase plates, custom delivered for each unit
- Results: Vacuum, LEO, quality optics, lighter, smaller, in far less time at less cost

## **NASA Optical System Design**

**Optical Design** 





- NASA's FF PP NT (freeform, positive/positive tilt, and non-telecentric) mirror design is the assumed baseline for our design
- We have from NASA a description for an initial design case with assembly and manufacturing errors
  - Described with Zernike Polynomials
- Now designing an optimal GRIN material and 3D free-form profiles, with new design tools, to correct the as-built aberrations
  - **o** Because we are not at the pupil, optic path modifications affect each field differently
  - Need to select a single or dual corrector plate architecture

## **Phase I Optical Design Meets Objectives**



Voxtel Design w/two FFG PCPs

- NASA's optic system design for Phase I
  - Entrance Pupil Dia: 50 mm, FOV: 2.86° x 8.73°, Focal Length: 250 mm
  - λ = 587.56 nm

**Optical Design** 

• Dual freeform GRIN (FFG) phase corrector plate (PCP) design is 1<sup>st</sup> Phase II target

RMS Spot	Baseline	Field-	Aperture-	Both
Diam. (mm)		Side	Side	
		GRIN	GRIN	
Min	0.0186	0.0126	0.0068	0.0032
Max	0.0331	0.0191	0.0231	0.0082
Avg	0.0239	0.0147	0.0141	0.0054
Std Dev	0.0036	0.0016	0.0039	0.0012



Summary table (above) and cross section Index maps for (top) aperture side alone, (middle) aperture side w/both, and (bottom) field side w/both FFG optics from Voxtel's Phase I research

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#### Phase II Optical Design Work ANSI standard ZERNIKE MODE PYRAMID RADIAL ORDER (n) Zernike term 0.04 WVF (mode) map 7 VALLEY 0.02 ARERRATION PISTON 1st order aberrations Polynomia Coefficient ( $\mu$ m) ordering number 0.00 VERTICAL TILT 2nd order aberrations -0.02 LOWER ORDERS HIGHER ORDERS -0.04 3rd order -0.06 VERTICA COMA -0.08 -0.10 10 15 OBLIQUE Zernike -3 -2 -1 0 1 # Combined OPD ANGULAR MERIDIONAL FREQUENCY (m)

### Zernike Polynomial Terms

Term Combinations

correction plate

In Phase II we will

**Optical Design** 

- Explore using other freeform mirror coefficients, as only originals were varied in Phase I
- Explore using spacing and angular tilts of freeform mirrors (fixed in Phase I) Ο
- Polychromatic performance tools are being created for Code V and implemented 0
- Refractive index range ( $\Delta n$ ), rate of index change variation across FFG PCP constrained by VIRGO Ο
- Printed area and volume constrained by cubesat optic path (e.g., 50 mm diameter) 0
- NASA Provides, for final design and interim experiments; •
  - Assembly and alignment geometry tolerances and expected errors (test cases)
  - Freeform mirror aberrations (as Zernike polynomials)
- With this information, we will select type of PCP •
  - Simple corrector, or with optical power
  - One or two phase corrector plates 0

#### Phase Corrector Plate Fabrication

## Fabricating Freeform Gradient (FFG) PCP w/VIRGO



160 μm pitch, 32,400 lens array



Plano 4 mm GRIN (left) & GRIN w/62 mm convex (right)



0.5 mm Hex Pack Hogel Lens Array



Freeform diamond-turned 12 mm f5, w/convex 200 mm radius





45 mm phase corrector plate (PCP) on an optic flat

- Volumetric Index of Refraction Gradient Optics (VIRGO) process in development
- In earlier NASA work (Contract NNX14CG41P) we fabricated PCP on optic flats
- FFG PCP's are to be printed on 1/10<sup>th</sup> wave fused silicon or glass substrate
- Optical ink will be optimized for this application (minimizing 2<sup>nd</sup> order dispersion)

Volumetric Index of Refraction Gradient Optics (VIRGO)

#### VOXTELNANO

### **Additive Manufacture of Freeform GRIN Optics**



• 24-hour design and build cycle time

#### Phase Corrector Plate Fabrication

## **VIRGO Ink Jet Print Fabrication Process**



3D Freeform GRIN Design (FFG PCP)

Conversion from continuous to voxelated bitmap for printing

### **Fabrication process**

- Design parameter(s) chosen
- 3D GRIN profiles selected based on optimization
- Nanofiller concentration profiles developed based on:
  - **o** Nanoparticle diffusion
  - Number of inks used
    - Binary or multi-level optical index levels (grey scale)
    - Multiple spectral characteristics (Abbe number)
- Error diffusion halftone algorithm used to convert design to binary or multi-level bitmaps





Droplets on Substrate



Custom R&D Multi-head Ink Jet Print Platform

### Nanocomposite Inks Index Increases w/Nanocrystal Load



Index Linearity vs Nanoparticle Fill

Non-scattering, well-dispersed nanofiller concentrations create index gradients

- We combine liquid monomer with nanoparticles (NP) such as ZrO<sub>2</sub> for optical ink
- As NP loading increases, index increases; relationship is locally linear
  - Index measured with our abbe refractometer (repeatable to 4 decimals), and with a Woollam M44 Spectroscopic Ellipsometer for wide spectrum measurements
- NPs are distributed throughout body of optic to create gradient refractive index
- Liquid nanocomposites are polymerized (cured to a hard state) layer by layer

#### Nanocomposite Inks

### Nanocomposite Optical Ink Design



Index vs Wavelength (dispersion) for Ink Components



- Index change between high and low index optical inks can vary with wavelength, which produces all the normal chromatic aberrations
- Dispersion and partial dispersion of Δn over the spectrum is controlled by balancing NP dispersion in the formulation of high and low index ink
- Balance of optical power (total  $\Delta n$ ), partial dispersion, and chemical complexity
- Voxtel's custom fluoropolymer improves stability and optical power

#### Nanocomposite Process

**V O X T E L N A N O** 

### VIRGO Resolution Can Map 21 Zernike Polynomials



Zernike (5,5) w/successful 4 mm Voxtel GRIN lens, inset



- Comparison of Zernike polynomial (5,5) to measured phase image of VIRGO printed 4 mm plano GRIN lens (scaled to the 50mm Zernike aperture)
- Demonstrates that we can achieve the Zernike polynomial phase variation requirements, which vary slowly across a 50 mm aperture relative to 4 mm lens GRIN
- Demonstration accomplished on both research and production process

**Optical Design** 

### **New Design Tools**





A non-rotationally symmetric freeform mirror with polychromatic light

(Index)

A non-rotationally symmetric freeform GRIN with 587.56 light

- Dr. Julie Bentley, working with UR graduate students, is creating a non-rotationally symmetric GRIN optimization tool for this program
  - Integrates with CODE V as TFGRIN module
  - Free-form patterns, based on Zernicke polynomials in x,y plane and Legendre in z-axis
  - Will be polychromatic
  - Orthogonal and Improved *∆n* control during optimization
- Axial dependence can cancel out some aberrations or modify their field dependence
- Use stack of phase plates (corresponding to printed layers), integrate effect
- Currently monochromatic, already demonstrates otherwise unobtainable results
  - $\circ$  Because it is orthogonally modeled, we can add one aberration w/o additional aberrations
  - Requires higher order Legendre polynomials in z axis

#### Phase Corrector Plate Optical Characterization

## Digital Holographic Microscope for n(x,y,z) Detail



- Digital holographic microscopy (DHM) • allows for the extraction of both amplitude and phase information
- Quantitative mapping of phase delay through the sample
- Has been shown to accurately predict • optical performance



**Digitally Propagated** 

DHM radians and wave lens measurement, resultant expected focus, and actual focus

# VOXTELNANO

### **Phase II Program Technical Objectives**

Goals	Measurable Objective Metrics	Approach (How)
A. Enhance or Develop	• 0.4 to 3 μm	<ul> <li>Use both fluoropolymer and acrylate</li> </ul>
Optical Inks Capable	<ul> <li>&gt; 90% transmission</li> </ul>	based optical inks (e.g. VBX No. 8 3NP)
of Achieving NASA	• Δn of 0.12, ΔP <sub>d,f</sub> < 0.000001	• Use SiO <sub>2</sub> nanoparticles in low-index inks
Requirements	• <i>f/df</i> > 500	
	• d <i>n</i> /dT < 10 x 10 <sup>-6</sup> /K	
	• CTE < 20 x 10 <sup>-6</sup> m/(m K)	
B. Design phase-	• > 80% smaller psf, 4x FOV uniformity	<ul> <li>Use Zernike polynomials for optical</li> </ul>
corrector plates that	<ul> <li>5<sup>th</sup> order Zernike polynomials</li> </ul>	system aberrations & mount design
meet NASA	<ul> <li>30 waves max correction</li> </ul>	from NASA
Requirements	<ul> <li>25% reduction in optic size</li> </ul>	
C. Fabricate phase-	• <sup>1</sup> ⁄ <sub>2</sub> wave accuracy	Use Voxtel custom-designed printers
corrector plates that	<ul> <li>Include system assembly mounting</li> </ul>	• Print flat optics and polish as necessary
meet NASA	features	(Struers RotoPol-35 polisher)
Requirements	<ul> <li>impact energy &gt; 0.5 kJ/m<sup>2</sup></li> </ul>	
D. Characterize phase-	• ¼ wave characterization accuracy	Use Voxtel, UO, UR, OSU optic toolset
corrector plates that	<ul> <li>Compare with design intent</li> </ul>	<ul> <li>Digital Holographic Microscope</li> </ul>
meet NASA		<ul> <li>Zygo profilometer</li> </ul>
Requirements		<ul> <li>BYK Gardner haze-gard plus</li> </ul>
E. Achieve	• 100 temp cycle haze increase < 2%	Model mechanical system on COMSOL
environmental	<ul> <li>High vacuum, &lt; 1% TML</li> </ul>	ATAMI Instron Mechanical Tester
performance	• Cryogenic, 120 K	Voxtel dewars
necessary for NASA	• Δn of 0.12, T% > 90%, P <sub>d.f</sub> < 0.001%,	UO CAMCOR Vacuum chambers
mission	impact energy > 0.1 kJ/m <sup>2</sup> at vacuum,	
	cryogenic operating points	
F. Achieve radiation	<ul> <li>Radiation per plan</li> </ul>	<ul> <li>Perform radiation tests throughout</li> </ul>
performance that	• 1E12 p/cm <sup>2</sup> @ 0.1 MeV protons	program using NASA Radiation Effects
meets NASA	• 10E9 p/cm <sup>2</sup> @ 1.5 MeV protons	Test Facility
Requirements	• 5E12 e/cm <sup>2</sup> @ 0.1 MeV electrons	Quarterly tests
	• 2E9 e/cm <sup>2</sup> @ 1.5 MeV electrons	